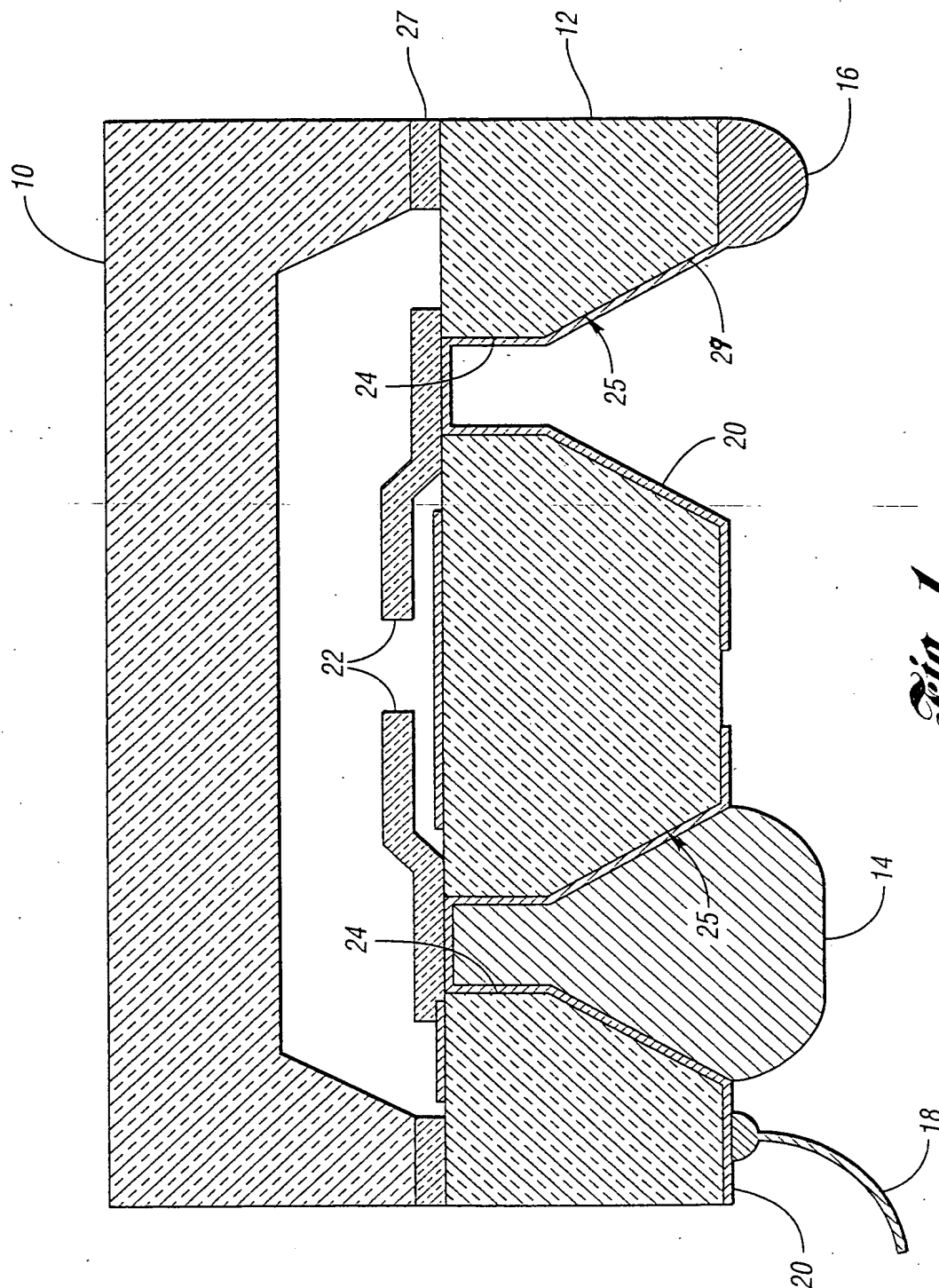


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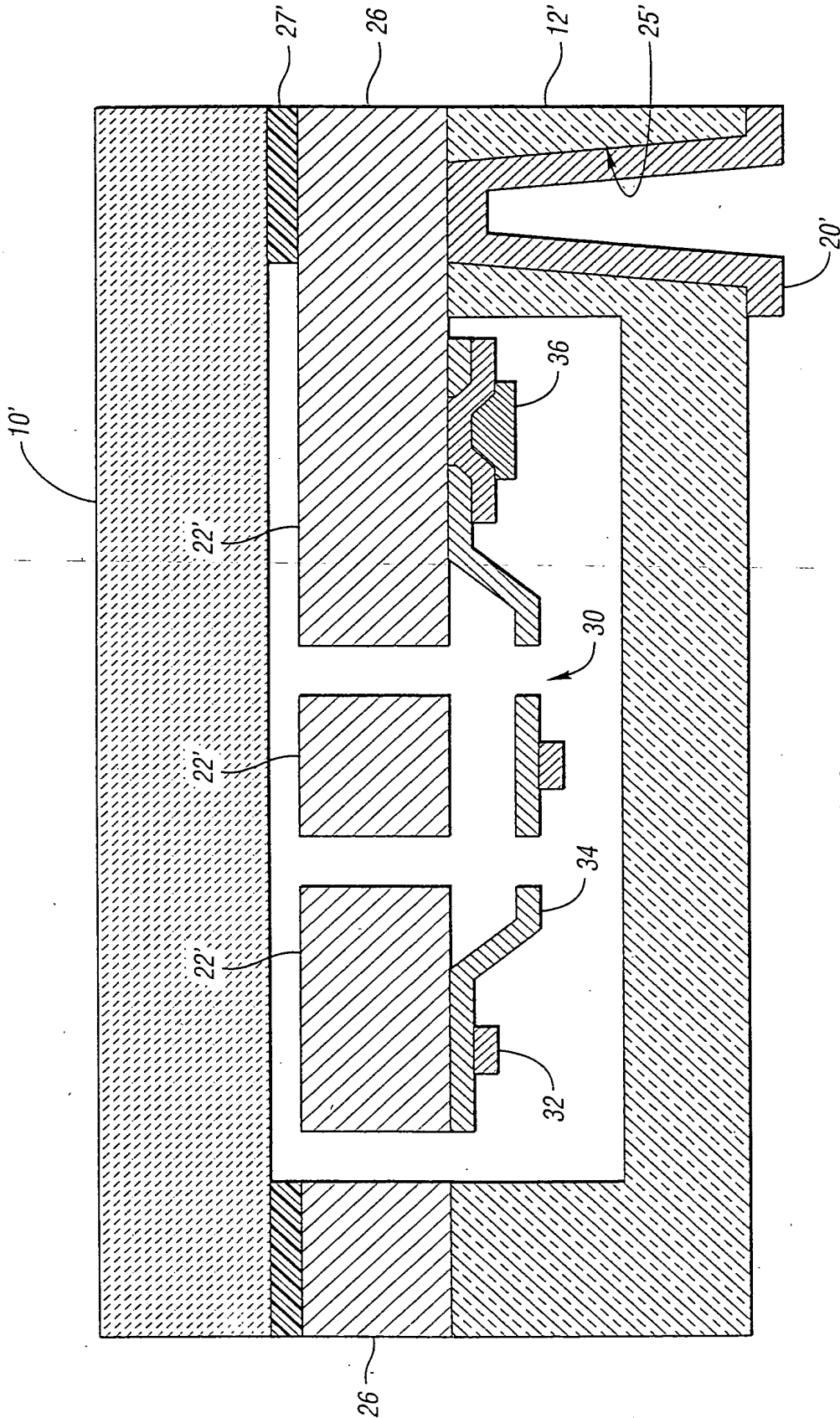
 $1/2$ 

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2. *Fig.*